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CONFIRMATION NO. 1783

SERIAL NUMBER 10/532,459	FILING OR 371(c) DATE 11/02/2005 RULE	CLASS 372	GROUP ART UNIT 2828	ATTORNEY DOCKET NO. AB-1432 US	
APPLICANTS Hyun-Jae Kim, Seongnam-city, KOREA, REPUBLIC OF; Myung-Koo Kang, Seoul, KOREA, REPUBLIC OF;					
** CONTINUING DATA ***** This application is a 371 of PCT/KR03/02212 10/21/2003					
** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 10-2002-0064511 10/22/2002					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 5	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 3
ADDRESS 32605					
TITLE Method of polycrystallization, method of manufacturing polysilicon thin film transistor, and laser irradiation device therefor					
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		